

FIG. 1

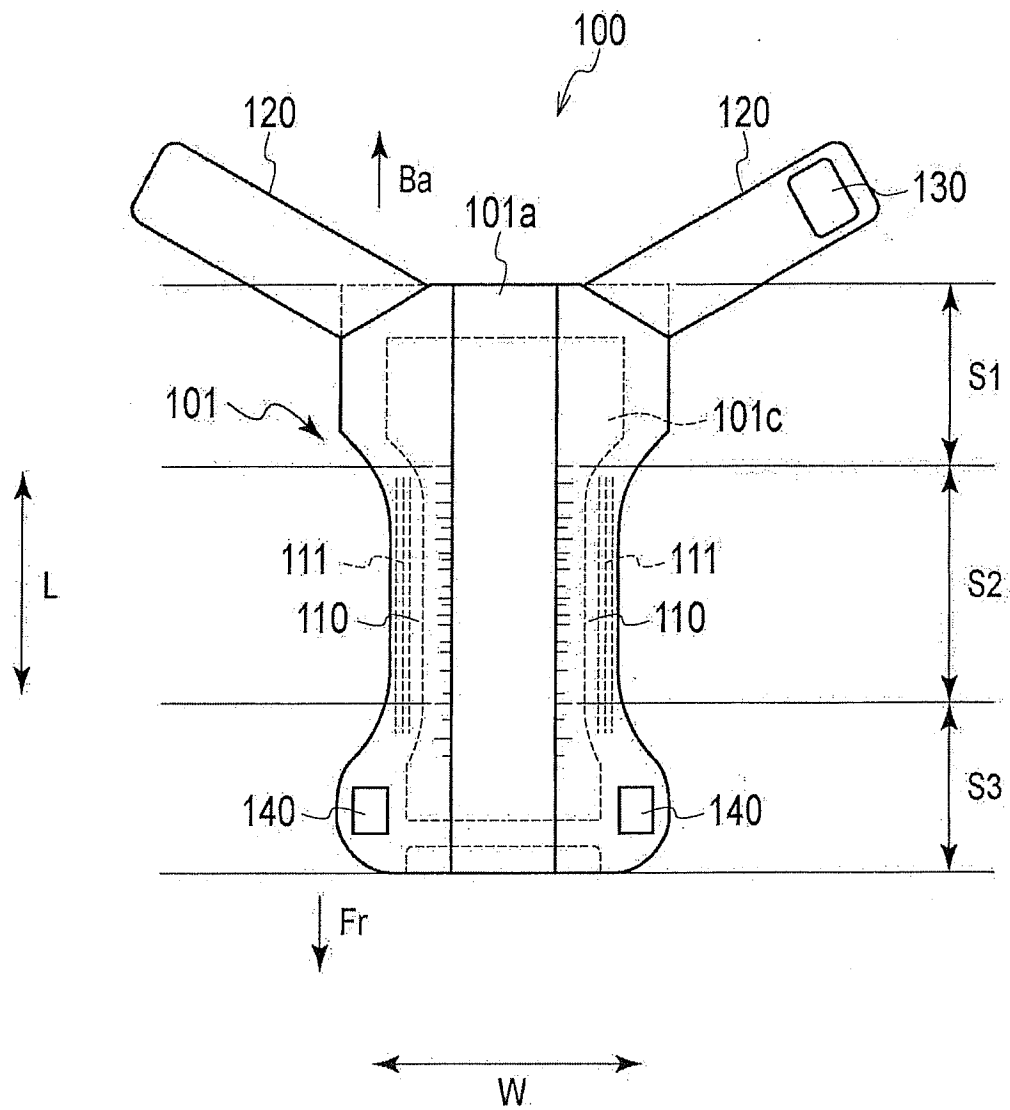


FIG. 2

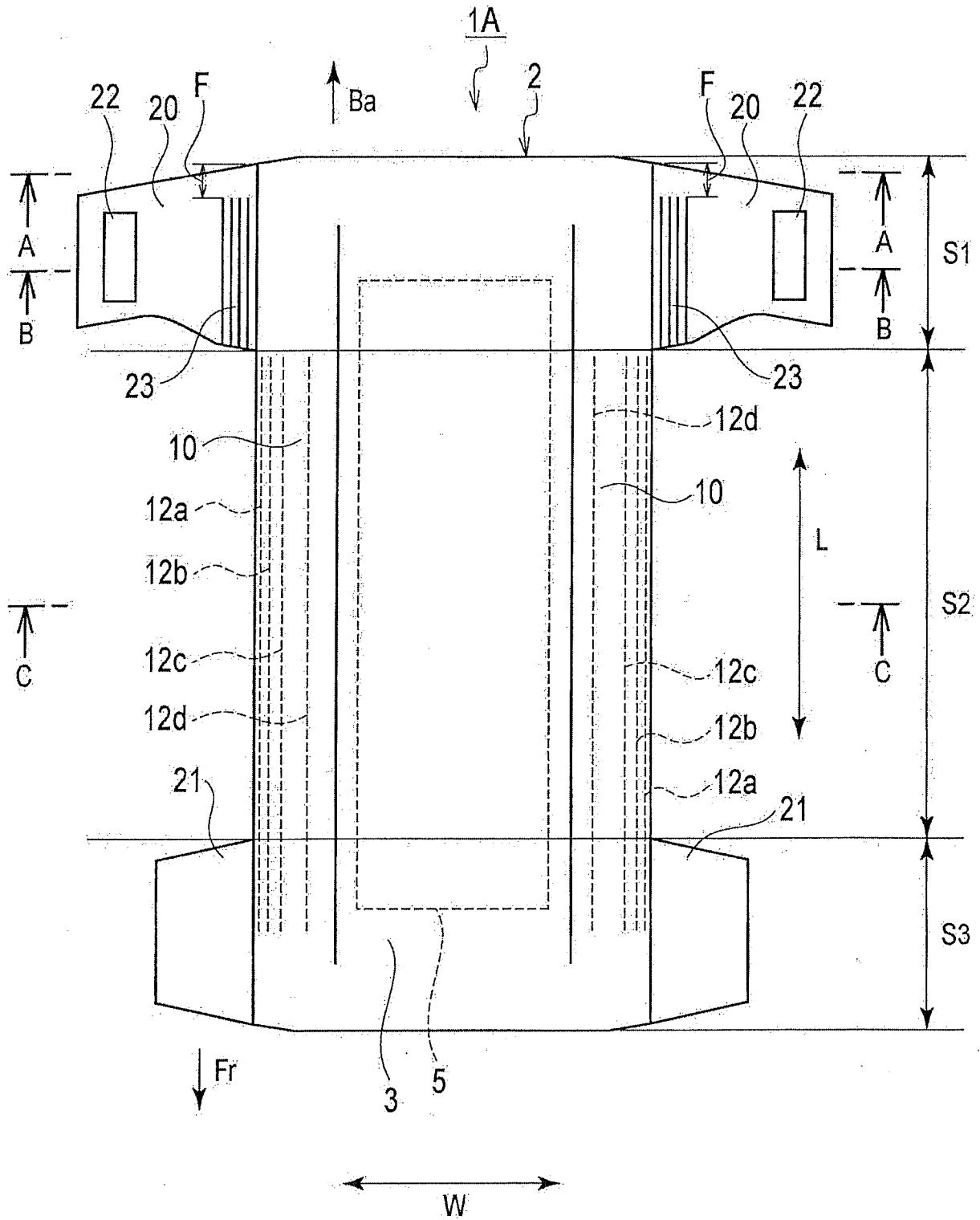


FIG. 3 is a schematic diagram of a device 100, such as a sensor, in a perspective view. The device 100 includes a substrate 10, a first conductive layer 20, a second conductive layer 30, and a third conductive layer 40. The first conductive layer 20 is disposed on the substrate 10. The second conductive layer 30 is disposed on the first conductive layer 20. The third conductive layer 40 is disposed on the second conductive layer 30. The device 100 is configured to sense a change in the resistance of the first conductive layer 20 in response to a change in the resistance of the second conductive layer 30.

FIG. 3

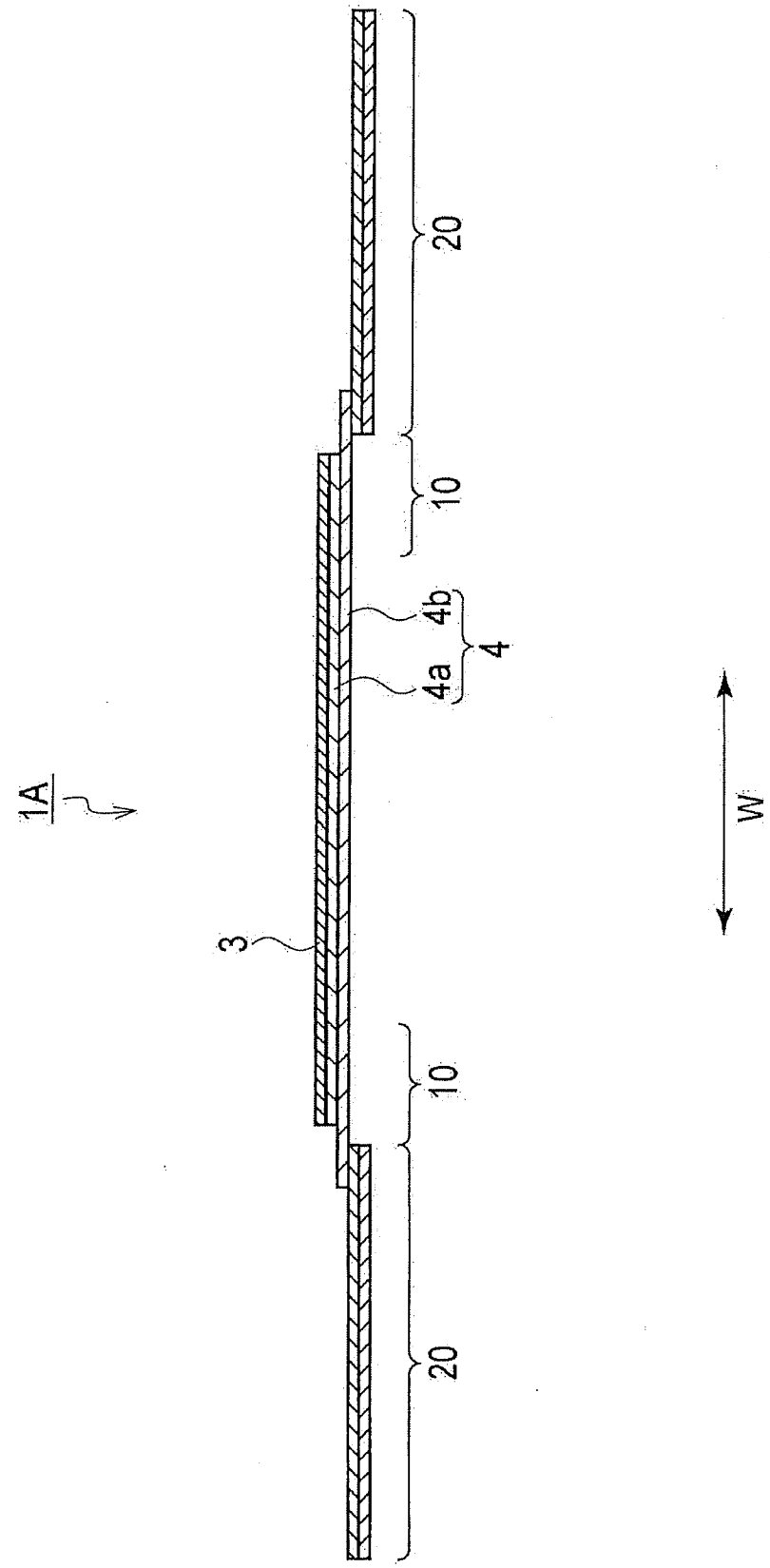


FIG. 4

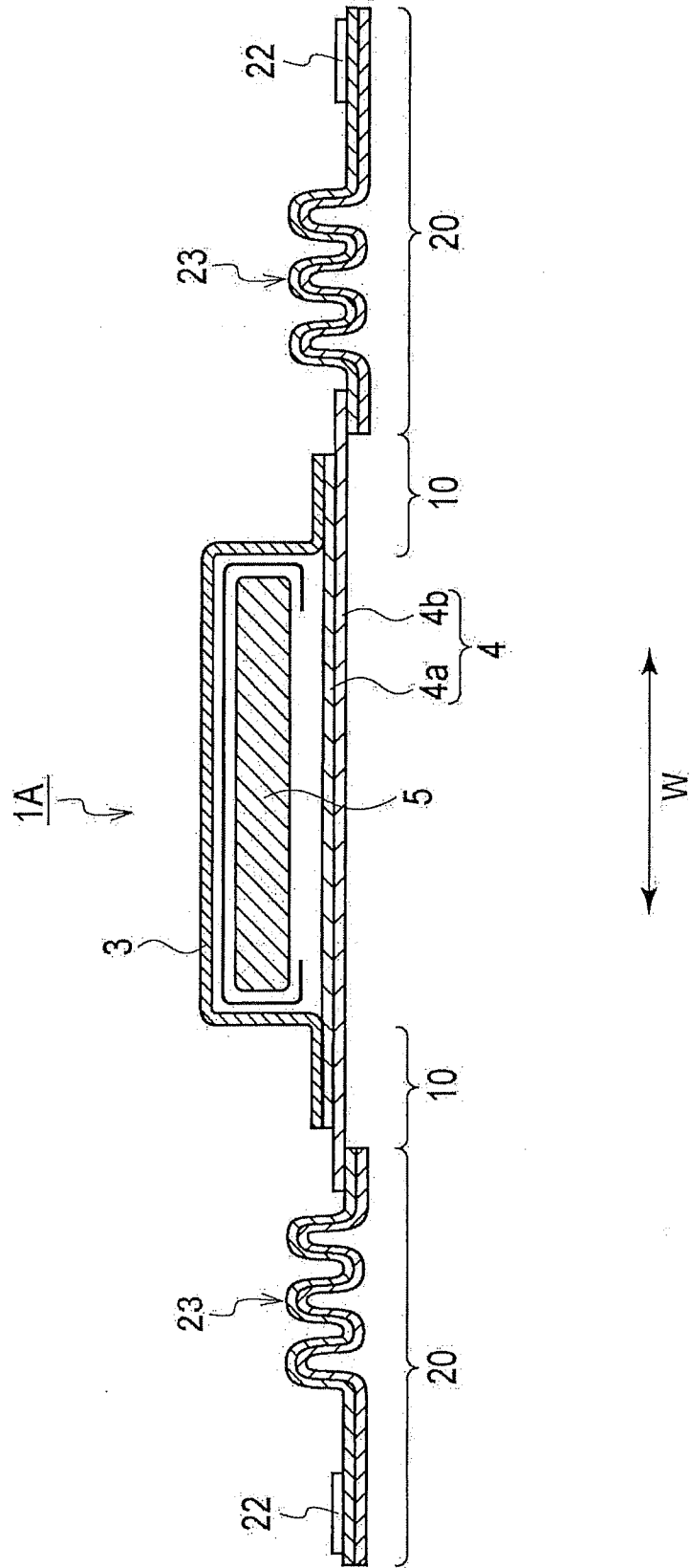


FIG. 5

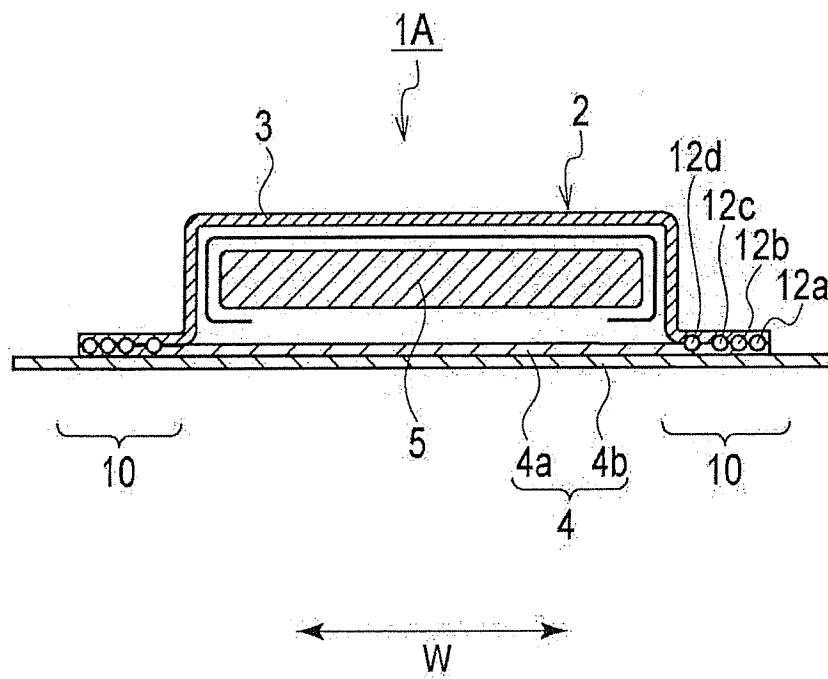


FIG. 6

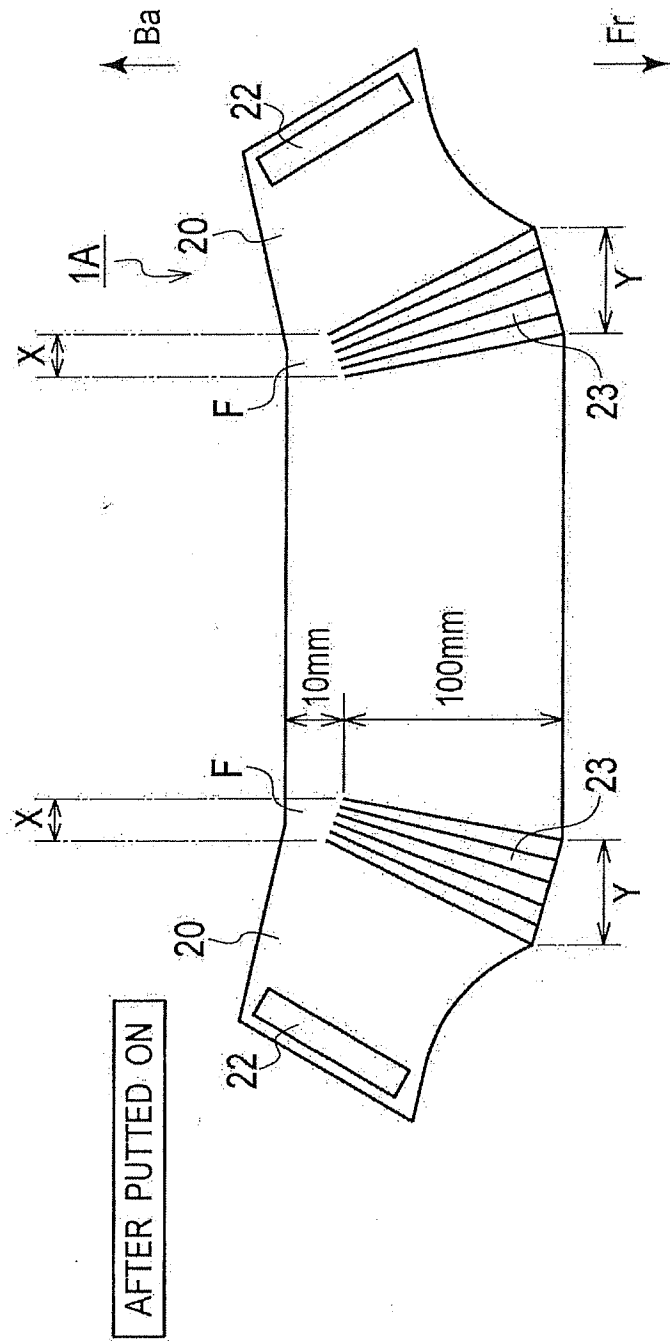


FIG. 7

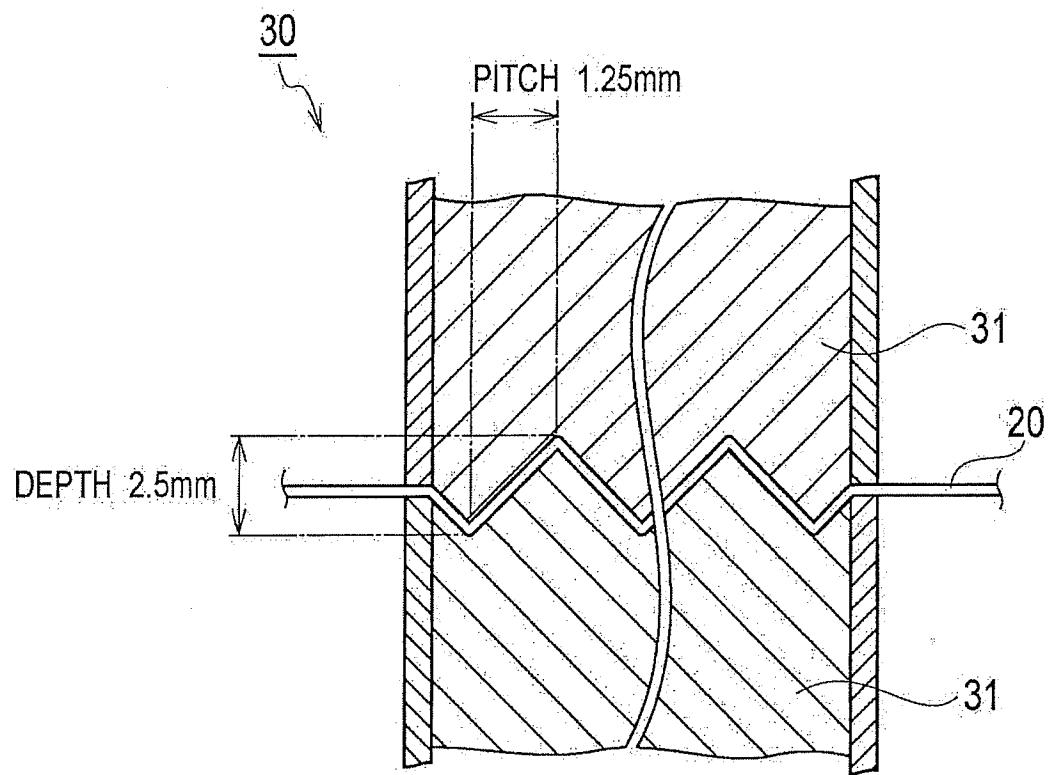


FIG. 8

